

Japan TC Chapter of Automation Technology Global Technical Committee Meeting Summary and Minutes

Japan Standards Spring 2015 Meetings
Thursday, April 9, 2015, 2:00 p.m. – 3:40 p.m.
SEMI Japan office, Tokyo, Japan

Next Committee Meeting

TBD, <Japan Standard Time>
Tokyo, Japan

Committee Announcements (optional)

None

Table 1 Meeting Attendees

Italics indicates virtual participants

Co-Chairs: Makoto Ishikawa (Nisshinbo Mechatronics), Ken Sambu (Mitsubishi Electric), Terry Asakawa (Tokyo Electron)

SEMI Staff: Chie Yanagisawa (SEMI Japan)

Attendee: 3 + **SEMI:** 1

<i>Company</i>	<i>Last</i>	<i>First</i>	<i>Company</i>	<i>Last</i>	<i>First</i>
Nisshinbo Mechatronics	Ishikawa	Makoto	Tokyo Electron	Murata	Naoko
Tokyo Electron	Asakawa	Terry	SEMI Japan	Collins	Junko

e

Table 2 Leadership Changes

None

Table 3 Ballot Results (or move to Section 4, Ballot Review)

None

Table 4 Authorized Ballots (or move to Section 7, New Business)

None

Table 5 Authorized Activities (or move to Section 7, New Business)

None

Table 6 New Action Items (or move to Section 8, Action Item Review)

None

Table 7 Open Actions Items (or move to Section 8, Action item Review)

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
20140729-2:	Japan members of Global EIS TF	To review the SNARF # 5222 => OPEN

1 Welcome, Reminders, and Introductions

Makoto Ishikawa (Nishinbo Mechatronics), co-chair, called the meeting to order at 2:04 p.m. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed by SEMI Staff. Attendees introduced themselves.

Attachment: Required_Elements_Reg_20150327_E+J

2 Review of Previous Meeting Minutes

The committee reviewed the minutes of the previous meeting.

Motion:	To approve the previous meeting minutes written as it is.
By / 2nd:	Naoko Murata (Tokyo Electron) / Terry Asakawa (Tokyo Electron)
Discussion:	None
Vote:	2 in favor and 0 opposed. Motion Passed.

3 Liaison Reports

3.1 Europe TC Chapter

Junko Collins (SEMI Japan) reported that Automation Technology TC Chapter in Europe is still on Standby. No special topic to be reported for this meeting.

3.2 SEMI Staff Report

Junko Collins (SEMI Japan) gave the SEMI Staff Report. Of note:

- Global SEMI Events
- Global Standards Meetings Schedule
- SEMICON Japan Meeting Schedule
- Ballot Critical Dates
- New Regulations and Procedure guide
- Contact Information

Attachment: SEMI Staff Report 2015 April R0.3b
HQ Report to RSCs March 2015 v2

Note: the Regs_SC_to_NARSC2015_0329_rev1.0 has been updated after this meeting. For readability issues, the revised file has been attached to this meeting minutes.

4 Ballot Review

None

5 Subcommittee & Task Force Reports

5.1 Equipment Interface Specification (EIS) Task Force

There was no special report from the task force.

Attachment: no attachment

6 Old Business

6.1 No

7 New Business

7.1 No

8 Action Item Review

8.1 *Open Action Items*

Junko Collins (SEMI Japan) reviewed the open action item. This can be found in the Open Action Items table at the beginning of these minutes. 20140729-2 is still open.

8.2 *New Action Items*

None

9 Next Meeting and Adjournment

Staff will coordinate the next meeting as soon as possible after this meeting. (J. Collins)

The meeting was adjured at 3:40PM

Respectfully submitted by:
Junko Collins
Director, Standards & EHS
SEMI Japan
Phone: +81.3.3222.5819
Email: cyanagisawa@semi.org

Minutes approved by:

<Makoto Ishikawa> (Nisshinbo Mechatronics), Co-chair	**
<Terry Asakawa> (Tokyo Electron), Co-chair	**

Table 8 Index of Available Attachments #1

<i>Title</i>	<i>#</i>	<i>Title</i>
SEMI Staff Report 2014 December_R0.3a	02	EIS_141209a

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact [SEMI Staff Name] at the contact information above.